

<b>Notice of References Cited</b>	Application/Control No. 10/764,223		Applicant(s)/Patent Under Reexamination RIEKE, PETER C.	
	Examiner Cachet I. Sellman		Art Unit 1762	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0113478 A1	06-2003	Dang et al.	427/535
*	B	US-4,131,696	12-1978	Covington, William	427/164
*	C	US-3,761,299	09-1973	Lidel	427/547
*	D	US-5,340,451	08-1994	Buchwalter et al.	204/165
*	E	US-5,346,728	09-1994	Yoshida, Yasuhiko	427/569
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	WO 91/17286 Tarasevich et al., "Proces sfor Depositing thin film layers onto surfaces modified with organic functinal groups", 11/14/1991
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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